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APPLICATION NO.	. 1	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/813,166		03/31/2004	Yoshiki Hirano	033897-005	4457	
21839	7590	08/23/2005		EXAMINER		
		ERSOLL PC	GURZO, PAUL M			
POST OFF		IS, DOANE, SW 1404	ART UNIT	PAPER NUMBER		
ALEXAND	DRIA, VA	22313-1404	2881			
			DATE MAILED: 08/23/2005			

Please find below and/or attached an Office communication concerning this application or proceeding.

					111			
		Applicati	on No.	Applicant(s)				
		10/813,1	66	HIRANO ET AL.				
	Office Action Summary	Examine	7	Art Unit				
		Paul Gurz	_	2881				
Period fo	The MAILING DATE of this commun or Reply	ication appears on the	e cover sheet with the	correspondence address				
THE - Exte after - If the - If NO - Failt Any	ORTENED STATUTORY PERIOD FOR MAILING DATE OF THIS COMMUNI INSIGNS OF THIS COMMUNI INSIGNS OF THIS COMMUNIANS OF THE MONTHS FROM THE MAILING DEPTH OF THE MONTHS FROM THE MONTHS FROM THE MONTHS FROM THE MONTHS FROM THE MONTHS THE MON	CATION. of 37 CFR 1.136(a). In no ev nunication. 0) days, a reply within the stal atutory period will apply and w will, by statute, cause the app	ent, however, may a reply be ti utory minimum of thirty (30) da ill expire SIX (6) MONTHS fror lication to become ABANDON	mely filed ys will be considered timely, n the mailing date of this communic ED (35 U.S.C. § 133).	cation.			
Status								
1)	Responsive to communication(s) file	ed on 28 July 2005.						
·	This action is FINAL. 2b)⊠ This action is non-final.							
3)	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
Disposit	ion of Claims							
5)□ 6)⊠ 7)□	Claim(s) 1-12 is/are pending in the application.  4a) Of the above claim(s) 1-6 and 11 is/are withdrawn from consideration.  Claim(s) is/are allowed.  Claim(s) 7-10 and 12 is/are rejected.  Claim(s) is/are objected to.  Claim(s) are subject to restriction and/or election requirement.							
Applicat	ion Papers							
10)⊠	The specification is objected to by the The drawing(s) filed on 31 March 20 Applicant may not request that any objected to specific production of the oath or declaration is objected to	<u>04</u> is/are: a)⊠ acce ction to the drawing(s) the correction is requi	be held in abeyance. So red if the drawing(s) is o	ee 37 CFR 1.85(a). bjected to. See 37 CFR 1.1				
Priority	under 35 U.S.C. § 119							
12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  a) ☐ All b) ☐ Some * c) ☐ None of:  1. ☐ Certified copies of the priority documents have been received.  2. ☐ Certified copies of the priority documents have been received in Application No  3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).  * See the attached detailed Office action for a list of the certified copies not received.								
2) Noti 3) Info	nt(s) ce of References Cited (PTO-892) ce of Draftsperson's Patent Drawing Review (F rmation Disclosure Statement(s) (PTO-1449 or er No(s)/Mail Date <u>8/11/04</u> .		4) Interview Summar Paper No(s)/Mail I 5) Notice of Informal 6) Other:					

## **DETAILED ACTION**

#### Election/Restrictions

Applicant's election without traverse of claims 7-12 in the reply filed on 7/28/05 is acknowledged. However, claim 11 is dependent on withdrawn claim 1. Therefore, claim 11 is also withdrawn and claims 7-10 and 12 will be examined.

### Claim Rejections - 35 USC § 112

The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

Claims 7-10 and 12 are rejected under 35 U.S.C. 112, second paragraph, as being incomplete for omitting essential elements, such omission amounting to a gap between the elements. See MPEP § 2172.01. The omitted elements are: there is no claimed language in claim 7 as to how the attachment is inhibited. The specification teaches that electromagnetic waves at a frequency matching the absorption band of H<sub>2</sub>O heats the H<sub>2</sub>O thereby inhibiting metal ion attachment to the H<sub>2</sub>O molecules (page 19). These parts and steps are essential for the apparatus to function. Further, there is no basis in the specification for how the unit can inhibit attachment to specific molecules. It can inhibit attachment to a group of molecules, like H<sub>2</sub>O, but it does not selectively inhibit individual molecules, only individual groups.

## Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

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Claim 7 is rejected under 35 U.S.C. 103(a) as being unpatentable over Shiokawa et al. (6,590,205).

Regarding claim 7, 205 teaches an ion attachment mass spectrometry apparatus causing positively charged metal ions to attach to analyte molecules to be measured in an attachment region to generate attached ions and then performing mass spectrometry on said attached ions by a mass spectrometer, comprised of a metal ion emitter (20) for emitting said metal ions to said attachment region, an introduction unit (22) for introducing said analyte molecules into said attachment region, and a mass spectrometer (13) for performing said mass spectrometry on said attached ions (col. 6, line 35 - col. 7, line 50 and Fig. 2). 205 does not explicitly teach a metal ion attachment inhibiting unit for inhibiting attachment of said metal ions to specific molecules in said attachment region. However, Fig. 7 depicts a hole (51a) where the metal ions pass through and attach to the analyte molecules, and a hole (51b) for the ions to pass through as they continue on to the mass spectrometer (13) (col. 9, lines 29-48). Each of the these holes (51a or 51b) will act as a metal ion attachment inhibiting unit because they will retard the flow of the metal ions and therefore prevent at least some of the ions from attaching to the molecules in the region. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to inhibit attachment to achieve improved accuracy of analysis of the sample by the mass spectrometer.

#### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Paul Gurzo whose telephone number is (571) 272-2472. The examiner can normally be reached on M-Fri. 7:30 - 6:00.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John Lee can be reached at (571) 272-2477. The fax phone number for the organization where this application or proceeding is assigned is (571) 273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

**PMG** 

SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2800